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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
09/450,491	11/29/1999	RYOICHI YOKOYAMA	YKI-0024	7688	
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CANTOR COLBURN, LLP			EXAMINER		
55 GRIFFIN R BLOOMFIELI			ABDULSELAM, ABBAS I		
			ART UNIT	PAPER NUMBER	
			2674	11	
			DATE MAILED: 05/21/2003	110	

Please find below and/or attached an Office communication concerning this application or proceeding.

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		Application No.		Applicant(s)
		09/450,491		YOKOYAMA, RYOICHI
Office Action Su	ımmary	Examiner		Art Unit
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The MAILING DATE of Period for Reply	this communication ap	ppears on the cove	r sheet with the co	orrespondence address
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1)⊠ Responsive to commu	inication(s) filed on 02	May 2003		
2a)☐ This action is FINAL .		his action is non-f	inal	
<i>-</i>	•—			secution as to the merits is
closed in accordance vi Disposition of Claims				
<u> </u>	anding in the application			
4) Claim(s) <u>1-18</u> is/are pe			-4'	
4a) Of the above claim(s		awn trom consider	ation.	
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8)☐ Claim(s) are sub Application Papers	ject to restriction and/	or election require	ment.	
9) The specification is object	cted to by the Examin	or		
10)☐ The drawing(s) filed on _	•		ed to by the Exam	iner
Applicant may not reque			-	
11)☐ The proposed drawing or				
If approved, corrected dr				od by the Examiner.
12)☐ The oath or declaration is		• •		
Priority under 35 U.S.C. §§ 119				
13)☐ Acknowledgment is made		an nriority under 34	SUSC & 110(a)-	(d) or (f)
a) ☐ All b) ☐ Some * c) ☐		in phoney and or oc	7 0.0.0. § 110(a)-	(4) 01 (1).
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	om the International Bo	ureau (PCT Rule 1	17.2(a)).	•
14)☐ Acknowledgment is made	of a claim for domes	tic priority under 3	5 U.S.C. § 119(e)	(to a provisional application
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ttachment(s)		-		
Notice of References Cited (PTO-85) Notice of Draftsperson's Patent Drafts) Information Disclosure Statement(s)	wing Review (PTO-948)	4) 5) 6)		PTO-413) Paper No(s) tent Application (PTO-152)
Patent and Trademark Office O-326 (Rev. 04-01)	Office A	action Summary		Part of Paper No. 16

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DETAILED ACTION

Claim Rejections 35 U.S.C. 103

- 1. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 1, 3-6, 9, 11-14 and 17-18 are rejected under 35 U.S.C. 103(a) as being unpatentable over Tornqvist (USPN 5133036) in view of Ishii et al. (USPN 5321536) and Nishimura et al. (USPN 4297004).

Regarding claims 1 and 9, Tornqvist teaches the first electrode structure (9), luminous multilayered thin film structure (10, 11, 12). second electrode structure (13, 14). See fig 2, and 3. Tornqvist teaches about transparent second electrode structure containing parallel electrode conductors. Tornqvist also teaches that the second electrode structure is provided with a narrow stripe (14) of high electrical conductivity. Moreover, Tornqvist teaches about electroluminescent thin film structure of a display unit and the use of emission filter material. See column 1, lines 7-13, and Column 3, lines 55-65. Tornqvist teaches visible emissions achieved by connecting an electric field over two electrodes and light is produced in a phosphor material placed between the electrodes. See col. 1, lines 14-22. However, Tornqvist does not teach connection of a second electrode with a signal supply such that the second electrode is controlled separately from the first

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electrode. Ishii on the other hand teaches the use of a first electrode and a second electrode in a such a way that the second electrode is controllably connected to and separated from the signal line by the photosensitive section. See col. 4, lines 30-36.

Therefore, it would have been obvious to one skilled in the art at the time the invention was made to modify Tornqvist's display system to include Ishii's electrodes configuration with a signal line. One would have been motivated in view of the suggestion in Ishii that the desired connection between an electrode and a signal supply as well as separate control of the electrodes can be achieved by Ishii's electrodes configuration with the signal line. The use of electrodes in conjunction with a signal line helps function the liquid crystal display as taught by Ishii.

Tornqvist has been described above. However, Tornqvist does not teach a multi layer structure having a resistance lower than a resistance of a single layer of the second electrode material. Nishimura on the other hand teaches a multi-layer lead electrode structure having an electrode resistance smaller than the thin-film lead electrodes.

Therefore, it would have been obvious to one skilled in the art at the time the invention was made to modify Tornqvist's display system to adapt Nishimura's multi-layer lead electrode.

One would have been motivated in view of the suggestion in Nishimura that the multi layer lead electrode is functionally equivalent to the desired multi layer structure. The use of multi layer lead electrode helps function liquid crystal display system as taught by Nishimura.

Regarding claims 3, and 11, Tornqvist teaches about a thin-film electrode layer, which is partly metallic or a metal alloy. See column 2, lines 22-33.

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Regarding claims 4 and 12, see Fig 3 (13, 14)

Regarding claims 5, and 13, Tornqvist teaches about layers (10, 11, 12) between first electrode (9) and second electrode (13, 14). See Column 3, lines 45-50, and Fig 2.

Regarding claims 6 and 14, Tornqvist teaches about photolithography and HCL etching. See, column 42-45, and 60-62.

2. Claims 2, 7-8 and 15-16 are rejected under 35 U.S.C. 103(a) as being unpatentable over Tornqvist in view of Ishiguro et al. (USPN 6146928).

Tornqvist has been described above. However, Tornqvist does not teach a type of thin film transistors containing a polycrystalline silicon layer, and does not disclose an external signal supply device connected to light emission panel. Also, Tornqvist does not teach conducting materials of conductors in connection to a gate electrode, drain electrode, and source electrode. Ishiguro on the other hand teaches about a thin film transistor containing a polycrystalline silicon layer (17) with respect to gate electrode (19), source, and drain regions (20), See Fig 2(a), and Fig 2(b), column 4, lines 60-67, and column 5, lines 1-10. In addition Ishiguro teaches about external power source (1010) connected to liquid crystal panel (1006). See Fig 17. Therefore, it would have been obvious to one having skill in the art at the time the invention was made to modify Tornqvist's thin film matrix structure to include a polycrystalline silicon layer, use the same material for conductors as well as transistors, and connect an external power source to a

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light emission panel. One would have been motivated in view of Ishiguro that the desired polycrystalline silicon layer, external signal supply device, and the conductive material for the three electrodes (gate, drain, and source) are equivalent to a polycrystalline silicon layer, electric power source, and composing materials of a thin film transistor. The use of polycrystalline silicon layer, and electric power source, helps achieve a reliable thin film transistor as taught by Ishiguro.

Conclusion

3. The prior art made of record and not relied upon is considered to applicant's disclosure.

The following arts are cited for further reference.

U.S. Pat No. 5,710,454 to Wu

U.S. Pat No. 5,034,341 to Itoh

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4. Any inquiry concerning this communication or earlier communication from the examiner should be directed to **Abbas Abdulselam** whose telephone number is (703) 305-8591. The examiner can normally be reached on Monday through Friday (9:00-5:30).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Richard Hjerpe, can be reached at (703) 305-4709.

Any response to this action should be mailed to:

Commissioner of patents and Trademarks

Washington, D.C. 20231

or faxed to:

(703) 872-9314

Hand delivered responses should be brought to crustal park II, Crystal Drive, Arlington, VA, Sixth Floor (Receptionist).

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the Technology center 2600 customer Service office whose telephone number is (703) 306-0377.

Abbas Abdulselam

Examiner

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SUPERVISORY PATENT EXAMINER
TECHNOLOGY CENTER 2600